	Туре	L #	Hits	Search Text	DBs	Time Stamp	Comment
1	IS&R	L1	130	(310/328).CCLS.	FPRS; EPO; JPO; DERWE NT; IBM_T DB	2006/12/2 9 09:17	
2	IS&R	L2	81	(310/366).CCLS.	FPRS; EPO; JPO; DERWE NT; IBM_T DB	2006/12/2 9 09:39	
3	IS&R	L3	72	(310/366).CCLS.	US- PGPUB	2006/12/2 9 09:42	
4	IS&R	L4	933	(310/366).CCLS.	USPAT	2006/12/2 9 09:56	
5	IS&R	L5	378	(310/365).CCLS.	USPAT	2006/12/2 9 10:06	
6	IS&R	L6	78	(310/365).CCLS.	US- PGPUB	2006/12/2 9 10:07	·
7	IS&R	L7	142	(310/365).CCLS.	FPRS; EPO; JPO; DERWE NT; IBM_T DB	2006/12/2 9 10:09	
8	IS&R	L8	21	(310/363).CCLS.	FPRS; EPO; JPO; DERWE NT; IBM_T DB	2006/12/2 9 10:12	
9	IS&R	Ļ9	48	(310/363).CCLS.	1	2006/12/2 9 10:13	
10	IS&R	L10	217	(310/363).CCLS.	USPAT	2006/12/2 9 10:18	

	Туре	L #	Hits	Search Text	DBs	Time Stamp	Comment
11	BRS	L11	202	plies or laminats4) and electrode adj3 (net or mesh or screen)		2006/12/2 9 10:21	•

Page Lorz TW)

RESULT LIST

Approximately 161 results found in the Worldwide database for:

piezoelectric or electrostrictive in the title AND electrode and (net or mesh or screen) in the title or abstract (Results are sorted by date of upload in database)

1 MULTILAYER PIEZOELECTRIC DEVICE

Inventor: NAKAMURA SHIGENOBU (JP)

Applicant: KYOCERA CORP (JP)

EC: F02M51/06A; H01L41/047; (+1)

IPC: F02M51/06; H01L41/047; H01L41/083 (+11)

Publication info: EP1675190 - 2006-06-28

2 LAMINATED PIEZOELECTRIC ELEMENT AND ITS MANUFACTURING

METHOD

Inventor: SATO KAZUHIDE; HATTORI HIDEKAZU; (+1) Applicant: DENSO CORP

EC: H01L41/047; H01L41/083; (+1)

IPC: H01L41/083; F02M51/00; F02M51/06 (+9)

Publication info: JP2006041279 - 2006-02-09

3 PIEZOELECTRIC EXCITER

Inventor: KOBAYASHI KAZUHIRO; WATANABE KEITA Applicant: CITIZEN ELECTRONICS

EC: IPC: H04R17/00; H04R17/00

Publication info: JP2006033005 - 2006-02-02

ULTRASONIC TRANSDUCER EMPLOYING SUSPENDED

PIEZOELECTRIC PLATE

Inventor: Applicant: EUPHONIOS CORP (US)

EC: B06B1/06E2; G04F5/06B; (+1)

IPC: H04R17/00; B06B1/06; G04F5/06 (+6)

Publication info: GB1254037 - 1971-11-17

5 Piezoelectric element and touch screen utilizing the same

Inventor: KATSUKI TAKASHI (JP); NAKAZAWA

Applicant: FUJITSU LTD (JP)

FUMIHIKO (JP); (+2)

EC: H03H3/08; G06F3/033Z4A4; (+1)

IPC: G06F3/043; G06F3/033; G06F3/041 (+17)

Publication info: US2005073505 - 2005-04-07

6 Piezoelectric ink-jet head and its manufacturing method

Inventor: CHEN ZHIMING (CN); CAI ZHICHANG (CN) Applicant: FEIHE SCI & TECH CO LTD (CN)

EC: IPC: **B41J2/16**; **B41J2/16**; (IPC1-7): B41J2/16

Publication info: CN1611361 - 2005-05-04

7 Packed piezoelectric actuator and manufacturing method thereof

Inventor: CHEN ZHIMING (CN); TU SHENGLI (CN)

Applicant: FEIHE SCIENCE & TECHNOLOGY CO (CN)

EC: IPC: **B41J2/015**; **H01L41/22**; **B41J2/015** (+3)

Publication info: CN1599089 - 2005-03-23

8 LAMINATED PIEZOELECTRIC DEVICE AND INJECTION EQUIPMENT

Inventor: NAKAMURA SHIGENOBU Applicant: KYOCERA CORP

EC: IPC: F02M51/00; F02M51/06; H01L41/083 (+15)

Publication info: JP2005072325 - 2005-03-17

9 PIEZOELECTRIC ELEMENT ACTUATOR AND ITS MANUFACTURING

METHOD

Inventor: FUTAKUCHI TOMOAKI; SAKAI YUICHI; (+3) Applicant: TOYAMA PREFECTURE; TATEYAMA KAGAKU

KOGYO KK

EC: IPC: **B41J2/16**; **B41J2/045**; **B41J2/055** (+6)

Publication info: JP2004330724 - 2004-11-25

PIEZOELECTRIC OSCILLATION GYRO

Inventor: OKAMOTO KOICHI Applicant: NEC TOKIN CORP

EC: IPC: G01P9/04; G01C19/56; H01L41/09 (+9)

Publication info: JP2004198364 - 2004-07-15

Pago-1012 frod



Canadian Intellectual Property Office

Offica de la propriété intellectuelle du Canada Canadä

Français Strategis Contact Us Site Map

Help What's New Search About Us Canada Site Registration





CIPO Home

DATABASE

Patents Main Page PATENTS

Search Options

Basic

Number

Boolean

Advanced

Help

Content

Searching

Search Language

FAQ

Disclaimer

Foreign Patent Links

Decisions of the Commissioner of Patents

Trade-marks Database

Copyrights Database

Industrial Designs Database



Canadian Intellectual Property Office

Canadian Patents Database

Search Results

12/29/2006 - 10:59:53

Search

Query:

((piezoelectric or electrostrictive)) <AN

Query: ((piezoelectric or electrostrictive)) <AND> (((stack or laminat* or multilayer or layer*)) <in> abstract) <AND> (((mesh or screen or net)) <in> claims)

10 documents out of 1894939 matched your query. Click on its number to view the details of the document.

Note: All document detail pages now appear on a new Browser Window.

1.	<u>2542085</u>	METHODS OF PRODUCING CARBON LAYERS ON TITANIUM METAL	77%
2 . ·	2434179	METALLIC FLAT SEAL AND METHOD FOR THE PRODUCTION THEREOF	77%
3.	<u>2351285</u>	PRODUCTION OF DIAPHRAGMS	77%
4.	2334526	MULTI-COMPONENT UNIDIRECTIONAL GRAPHIC ARTICLE	77%
5.	2325928	PHOTOMATRIX DEVICE	77%
6.	2283528	DIRECT USES OF NEUTRINO ENERGY	77%
7.	2099089	PIEZOELECTRIC ELEMENT FOR KEYBOARDS	77%
8.	2096721	SURFACE SEPARATOR AND DISPERSION APPARATUS	77%
9.	<u>1294659</u>	SHEAR MOTOR FOR DYNAMIC MOUNT FOR LASER-BEAM STEERING MIRROR	77%

Searching PAJ

	MIENU NEWS HELP				
Search Results: 8 Index Indication Clear					
Text Search	If you want to conduct a Number Search, please click on the button to the right.	ımber Search			
Applicant,Title	of invention, Abstract — e.g. computer semiconducto	or			
•	R operation, please leave a SPACE between keywords. opwords are not searchable.				
electrostrictive	e electrode	AND 🔻			
	AND				
stack lamination	on multilayer layer	OR 🔽			
,	AND				
net mesh scre	en	OR ▼			
-	AND				
Date of publica	ation of application — e.g.19980401 - 19980405				
	-				
	AND				
IPC e.g. D01B7/	04 A01C11/02				
If you use the OR ope	eration, please leave a SPACE between keywords.				
•	¥				

Searching PAJ

MENU NEWS HELP	
Search Results: 126 Index Indication Cle	ar
Text Search If you want to conduct a Number Search, please click on the button to the right.	umber Search
Applicant, Title of invention, Abstract — e.g. computer semiconduct	or
If you use the AND/OR operation, please leave a SPACE between keywords. One letter word or Stopwords are not searchable.	
piezoelectric electrode	AND ▼
AND	
stack lamination multilayer layer	OR ▼
AND	
mesh screen net	OR ▼
AND	
Date of publication of application — e.g.19980401 - 19980405	
AND	
IPC — e.g. D01B7/04 A01C11/02	
If you use the OR operation, please leave a SPACE between keywords.	·
▼ ∜Search ** ** Stored data **	





IP SERVICES



IP Services PatentScope

Patent Search

Results of searching in PCT for:

(piezoelectric or electrostrictive or actuator or electromechanical) near (stack or laminat* or layer* or multilayer) and electrode near (mesh or net or screen): 3 records Showing records 1 to 3 of 3:

[Search Summary]

Refine Search (piezoelectric or electrostrictive or actuator or electrome



RSS 3

Title

Pub. Date 28.09.2006

H01M 12/06

Int. Class

Applicant

EVEREADY BATTERY COMPANY.

The invention is an electrochemical battery cell with a fluid consuming electrode, such as an oxygen reduction electrode, and a fluid regulating system. The fluid regulating system includes a valve for adjusting the rate of passage of the fluid to the fluid consuming electrode. It is operated by an actuator that responds (e.g., by deforming) to changes in a potential applied across the actuator to open or close the valve. The applied potential can be the cell potential or an adjusted potential. The potential applied across the actuator can vary according to the need for more or less fluid in the fluid consuming electrode. The valve can be contained within the cell housing, for example between the fluid consuming electrode and one or more fl...

2. (WO 2005/124918) ELECTROCHEMICAL METHODS, DEVICES, AND STRUCTURES

1. (WO 2006/101491) FLUID CONSUMING

BATTERY WITH FLUID REGULATING SYSTEM

29.12.2005

H01M 10/04

MASSACHUSETTS INSTITUTE OF

TECHNOLOGY

The present invention provides devices and structures and methods of use thereof in electrochemical actuation. This invention provides electrochemical actuators, which are based, inter-alia, on an electric field-driven intercalation or alloying of high-modulus inorganic compounds, which can produce large and reversible volume changes, providing high actuation energy density, high actuation authority and large free strain.

3. (WO 2005/055355) FLUID CONSUMING BATTERY WITH FLUID REGULATING SYSTEM 16.06.2005

H01L 41/04

EVEREADY BATTERY COMPANY,

The invention is an electrochemical battery cell with a fluid consuming electrode, such as an oxygen reduction electrode, and a fluid regulating system. The fluid regulating system includes a valve for adjusting the rate of passage of the fluid to the fluid consuming electrode. It is operated by an actuator that responds (e.g., by deforming) to changes in a potential applied across the actuator to open or close the valve. The applied potential can be the cell potential or an adjusted potential. The potential applied across the actuator can vary according to the need for more or less fluid in the fluid consuming electrode. The valve can be contained within the cell housing, for example between the fluid consuming electrode and one or more fl...

Search Summary

piezoelectric NEAR stack: 1214 occurrences in 287 records. piezoelectric NEAR mesh: 27 occurrences in 16 records.

(piezoelectric NEAR stack AND piezoelectric NEAR mesh): 0 records.

electrostrictive NEAR stack: 15 occurrences in 10 records. electrostrictive NEAR mesh: 0 occurrences in 0 records.

(electrostrictive NEAR stack AND electrostrictive NEAR mesh): 0 records.

((piezoelectric NEAR stack AND piezoelectric NEAR mesh) OR (electrostrictive NEAR stack AND electrostrictive

NEAR mesh)): 0 records.

actuator NEAR stack: 547 occurrences in 175 records. actuator NEAR mesh: 21 occurrences in 13 records.

(actuator NEAR stack AND actuator NEAR mesh): 1 record.